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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Mail Stop: ISSUE FEE**  
Akihisa HONGO et al. : **Confirmation No. 7681**  
Serial No. 09/842,650 : **Group Art Unit 1763**  
Filed April 27, 2001 : **Examiner S. Macarthur**

REVOLUTION MEMBER SUPPORTING  
APPARATUS AND SEMICONDUCTOR  
SUBSTRATE PROCESSING APPARATUS

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ACCOUNT NO. 23-0975

**RESPONSE TO NOTICE REGARDING DRAWINGS**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Notice Regarding Drawings mailed on February 17, 2005 for the above-identified application, enclosed herewith are Replacement Figures 1A-78 including the corrections required by the associated Notice of Draftsperson's Patent Drawing Review form. No new matter has been added in these replacement figures. As a result of the submission of these drawings, issuance of the application into a patent is respectfully requested.

Respectfully submitted,

Akihisa HONGO et al.

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